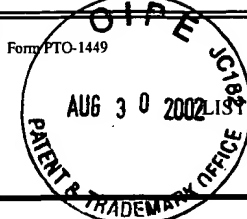


Form PTO-1449 <div style="text-align: center;">  </div>		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1114		SERIAL NO. 09/233,377	
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U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
T8	AA	6,376,372 B1	04/23/02	Paranjpe et al.			
T8	AB	4,897,368	01/30/90	Kobushi et al.			
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FOREIGN PATENT DOCUMENTS							
Document Number	Date	Country	Class	Subclass	Translation		
					Yes	No	
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AM							
AN							
AO							
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
T8	AR		Omar, M. Ali, "Elementary Solid State Physics," © 1975 by Addison-Wesley Publishing Company, Inc., pages 539-542 (6 pages total).
T8	AS		Wolf, et al., "Silicon Processing for the VLSI Era - Volume 1-Process Technology," ©1986 by Lattice Press, pages 242,261, 262, 303, & 304 (7 pages total).
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EXAMINER 	DATE CONSIDERED 4/4/03
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.